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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

) Attorney Docket No: LAM1P108D

)

MIKHAYLICH et al.

) Examiner: MARKOFF, A.

)

Application No: 10/766,733

) Group Art Unit: 1746

)

Filed: January 27, 2004

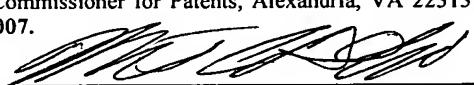
) Date: February 5, 2007

)

For: METHOD AND SYSTEM FOR)
CLEANING A SEMICONDUCTOR WAFER)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313 on February 5, 2007.

Signed: 

Michael L. Gencarella

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

In response to the Restriction Requirement dated January 5, 2007, the Applicants hereby elect, without traverse, Group 1, claims 1-11, to prosecute in the above-identified patent application. The Applicants reserve the right to file a divisional application covering the subject matter of the non-elected claims.

Should the Examiner have any questions concerning this matter, the undersigned can be reached at the telephone number set out below.

Respectfully submitted,
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